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Response Under 37 C.F.R. § 1.116
Examining Group 2826
Expedited Procedure

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jack O. Chu, et al. **Examiner:** Johannes P. MONDT
Serial No: 10/775,514 **Art Unit:** 2826
Filed: February 10, 2004 **Docket:** YOR920010308US3 (16315B)
For: EPITAXIAL AND POLYCRYSTALLINE GROWTH OF $\text{Si}_{1-x-y}\text{Ge}_x\text{C}_y$ AND $\text{Si}_{1-y}\text{C}_y$ ALLOY LAYERS ON Si BY UHV-CVD **Dated:** December 5, 2005

Confirmation Number: 1038

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

In response to the Final Office Action dated October 3, 2005, Applicants hereby submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop AF, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 5, 2005

Dated: December 5, 2005


Leslie S. Szivos, Ph.D.

N.B.: After-Final Amendment
NOT entered. Thank you. (12/14/05)